# Procedural Review Voting Sheet 2013 Cycle 7

**REGION: Japan** 

COMMITTEE: Silicon Wafer EVENT: SEMICON Japan 2013 DATE OF MEETING: 12/5/2013

PLACE OF MEETING: Makuhari Messe, Chiba, Japan

COMMITTEE CO-CHAIRS: Tetsuya Nakai/SUMCO, Naoyuki Kawai/The University of Tokyo

**SEMI STAFF: Hirofumi Kanno** 

A&R Voter: Name/Company

Date: 200X/MM/DD

#### I. Document Number & Title

Document	Document Title
5500	New Standard: Specifications for Polished Single
	Crystal Silicon Wafers for Gallium Nitride On
	Silicon Applications

#### II. Tally (Staff to fill in)

#### Voting Tally: As-cast tally after close of voting period

A minimum of 60% of the voting interests that have voting members within the technical committee must return votes. (Regulations  $\P$  9.6.1)

	Return	Distribution Return Rate	
Yellow	56	÷ 91 = 61.5% >	=60%
Lilac & Others	36		
Total Vote	92		
Reject	0		
Accept	20		

A&R	Not approved
Aur	Reason:

# III. Rejects None

### **IV. Comments**

### Comment 1

	Referenced Section			*TF/Committee to fill in if necessary
လ		Fr	om	Tetsuya Nakai (SUMCO)
Comment	Comment			Accept with Comment for SEMI Draft Document 5500 Do we need to consider possibilities for 6 inch notched wafers and 6 & 8 inch (110) wafers?
		Disc	ussion	This will be a new business in future development for specific application.
	X			tee agreed to do one of the following actions.
		*No	motion	is required in this step.
				er action was taken by the committee.
				the task force for more consideration.
		X	New Bus	siness
			Other	
	Editorial Change			
Act			Case 1:	No vote in this section :
Action proposed			To be in	cluded and voted on in <u>§ 5. Summary of Editorial Changes</u> .
rop			Case 2:	Voted in this section :
osed			Original "TO" fie	section number and at least one full sentence are required in "FROM" and elds.
			FROM:	Section xxx
		1	To: Sec	ction xxx
			Justific	ration (If necessary)
			FROM:	Section xxx
		2	To: Sec	ction xxx
			Justific	ation (If necessary)
ľ	Vloti	ion k	y/2nd	Friedrich Passek (Siltronic)/ Masanori Yoshise (Consultant)

Vote		15-0 Motion passed			
A&R	No	ot approved			
ACIN	Reason:				

## V. Summary of Editorial Changes

None

### **VI. Approval Conditions Check**

**APPROVAL CONDITION 1:** All negatives have been discussed and were withdrawn, found not related, or not persuasive. (Regulations ¶ 9.6.2)

**APPROVAL CONDITION 2:** At least 90% of the sum of the valid accept and reject votes must be accept. (Regulations ¶ 9.6.3)

Note: if both approval conditions are not satisfied, the document fails.

A&R		Not approved
Aur	Re	eason:

#### **VII. Safety Check**

See § 14 of the Regulations for further information

<b> </b>	X	This is not a Safety Document: when all safety-related information is removed, the document is still technically sound and complete.				
Motion:	This is a Safety Document: when all safety-related information is removed, the document is not technically sound and complete.					
		Safety Checklist (Regulations ¶ 14.3) is complete and has been included with the document throughout the balloting process.				
N	Motion by/2nd by Friedrich Passek (Siltronic)/ Masanori Yoshise (Consultant)					
	Discussion No			on	None	
Vote 13-0 Motion pas					13-0 Motion passed	
	A&F	,		Not a	pproved	
	ACI	`	Re	ason:		

VIII. Intellectual Property Check

Note: This ballot may be all or part of a Standard or Safety Guideline. This IP check applies to the entire Standard or Safety Guideline. See § 15 of the Regulations for further information

X	The meeting chair asked those present in person or by electronic link, if they were aware of any potentially material patented technology or copyrighted items* in the Standard or Guideline.								
	X		ootentially n known	GO TO SECTION IX					
		knov	entially mate wn but a Le n material h	GO TO SECTION IX					
		copy	Potentially material patented technology or copyrighted items are known but an LOA or copyright release for some of the material(s) has NOT been obtained or presented to the committee						
	M		Ask ISC f	or spec	cial permission to publish				
	MOTION		Quit activ	uit activity					
	Š		Wait for L	OA for	OA for patented technology or release of copyrighted items.				
	Motion by/2 <sup>nd</sup> by			Name (Company)/Name (Company)					
	Discussion			XXXX					
		Vo	te	XX-XX					
	Final Action				Motion Passed				
					Motion Failed				
Α.	.&R Not appro		ved						
A	O(IX	Reason:							

#### IX. Action for this document

	X	This document passed committee review as balloted and will be forwarded to the A&R for procedural review.								
Motion		This document passed committee review with editorial changes and will be forwarded to the A&R for procedural review.								
		Th	is do	cum	ment failed committee review and will be returned to the task force for rework.					
		Th	is do	cum	ent failed committee review and work will be discontinued.					
	Motion by/2nd by				Friedrich Passek (Siltronic) / Masanori Yoshise (Consultant)					
	Discussion				None					
	Vote				15-0					
	Final Act		al Action		X Motion passed					
					Motion failed					
	A&F	D		Ap	proved					
	АСТ			No	t approved					

<sup>\*</sup> Note: Such potentially material patented technology or copyrighted items might have become known since the Standard or Safety Guideline was last reviewed, or might become relevant due to this ballot.

Reason: